

52433/861

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Jiro KONDO, et al.
Serial No. : 10/591,093
Filed : August 29, 2006
For : METHOD FOR REMOVING BORON FROM SILICON
Examiner : Cohen, Stefanie J.
Art Unit : 1793
Confirmation No. : 7884

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I hereby certify this correspondence is being electronically transmitted to the United States Patent and Trademark Office via the Office electronic filing system on **October 14, 2010**

Signature: /Katy Chan-Parsons/
Katy Chan-Parsons

AMENDMENT

In response to the Final Office Action dated July 23, 2010, Applicants respectfully request entry of the following amendments and comments into the file of the above-identified application.

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 5 of this paper.